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FEB 1 0 2005 35

Date

Fébruary 10, 2005

PTO/SB/21 (08-03) Approved for use through 07/31/2006. OMB 0651-0031
U.S. Patent and Trademark Office: U.S. DEPARTMENT OF COMMERCE U.S. Patent and Trademark Office: U.S. DEPARTMENT OF COMMERCE
PRADE Pater the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it displays a valid OMB control number. Application Number 09/839,508 Filing Date **TRANSMITTAL** April 20, 2001 First Named Inventor **FORM** JEONG, In Kwon Art Unit 3723 (to be used for all correspondence after initial filing) Examiner Name A. Ojini Attorney Docket Number Total Number of Pages in This Submission 9323.054.00 **ENCLOSURES** (Check all that apply) After Allowance Communication Fee Transmittal Form Drawing(s) to Group Appeal Communication to Board of Fee Attached Licensing-related Papers Appeals and Interferences Appeal Communication to Group (Appeal Notice, Brief, Reply Brief) Amendment/Reply Petition Petition to Convert to a After Final **Proprietary Information Provisional Application** Power of Attorney, Revocation Affidavits/declaration(s) Status Letter Change of Correspondence Address Other Enclosure(s): RESPONSE Extension of Time Request Terminal Disclaimer TO RESTRICTION/ELECTION REQUIREMENT **Express Abandonment Request** Request for Refund Information Disclosure Statement CD, Number of CD(s) Certified Copy of Priority Document(s) Remarks Response to Missing Parts/ Incomplete Application Response to Missing Parts under 37 CFR 1.52 or 1.53 SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT Mark R. Kresloff, Reg. No. 42,766 Firm MCKENNA LONG & ALDRIDGE LLP Individual name Signature

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TECHNOLOGY CENTER R3700



Docket No.: 9323.054.00-US

(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

In Kwon JEONG

Confirmation No: 2893

Application No.: 09/839,508

Art Unit: 3723

Filed: April 20, 2001

Examiner: Ojini, A.

For: APPARATUS AND METHOD FOR

SEQUENTIALLY POLISHING AND

LOADING/UNLOADING SEMICONDUCTOR WAFERS

Customer No.: 30827

RESPONSE TO RESTRICTION/ELECTION REQUIREMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 RECEIVED

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Dear Sir:

TECHNOLOGY CENTER R3700

In response to the restriction/election requirement set forth in the Office Action dated January 24, 2005, the Applicant hereby elects to prosecute claims 1-6, 13-15, 21, and 22 which correspond to Species I illustrated in Figures 1-10 as set forth in the Office Action without traverse. In addition, the Applicant recognizes that upon the allowance of a generic claim, the Applicant will be entitled to consideration of claims depending therefrom which are directed toward additional species.

The Applicant believes each of the claims in elected Group I is in condition for allowance. Notice of same is earnestly solicited. If the Examiner believes that a telephone call would further the prosecution of the present application, the Examiner is encouraged to contact the Applicant's representative at the telephone number provided herein below.

Applicants hereby authorize the Commissioner of Patents to charge any fees necessary to complete this filing, including any fees required under 37 C.F.R. §1.136 for any 'Application No.: 09/839,508 2 Docket No.: 9323.054.00-US

necessary Extension of Time to make the filing of the attached documents timely, or credit any overpayment in fees, to Deposit Account No. 50-0911. Further, if these papers are not considered timely filed, then a petition is hereby made under 37 C.F.R. §1.136 for the necessary extension of time.

Dated: February 10, 2005

Respectfully submitted,

Mark R. Kresloff

Registration No.: 42,766

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